



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 7449
Kazuhiro OTSU et al. : Docket No. 2002-0208A
Serial No. 10/067,370 : Group Art Unit 2818
Filed February 7, 2002 : Examiner Thao P. Le

SEPARATING MACHINE FOR THINNED
SEMICONDUCTOR SUBSTRATE AND
SEPARATION METHOD

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated April 9, 2003 in which restriction has been required, Applicants hereby elect the invention identified as Group I (claims 1-5, and 9) without traverse.

Favorable action on the merits is now requested.

Respectfully submitted,

Kazuhiro OTSU et al.

By: Matthew Jacob
Matthew Jacob
Registration No. 25,154
Attorney for Applicants

MJ/jlg
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
May 9, 2003

Handwritten: #2
Official
5/13/03

RECEIVED
MAY 12 2003
TECHNOLOGY CENTER 2800